

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**SUPPLEMENTAL INFORMATION DISCLOSURE  
STATEMENT**

Docket Number  
10191/3964

Confirmation No.  
6739

Application Number  
10/530,612

Filing Date  
Dec. 30, 2005

Examiner  
Maki A. Angadi

Art Unit  
1732

Invention Title  
PLASMA SYSTEM AND METHOD FOR ANISOTROPICALLY ETCHING  
STRUCTURES INTO A SUBSTRATE

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I hereby certify that this correspondence is electronically  
transmitted to the USPTO via the Office of electronic filing system  
on September 17, 2009.

Signature: /Rita Hannan/  
Rita Hannan

Sir:

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. The filing of this Information Disclosure Statement and the attached PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
3. A copy of each patent, publication or other information listed on the modified PTO 1449 is enclosed, unless otherwise noted.
4. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a final action, Notice of Allowance, or any action that otherwise closes prosecution. No fee is required.
5. It is hereby certified that each item of information contained in this Supplemental Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Supplemental Information Disclosure Statement 37 CFR §1.97(e)(2).

Respectfully submitted,

Dated: September 17, 2009

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